

Hybrid Miniature Fabry–Perot Sensor with Dual Optical Cavities for Simultaneous Pressure and Temperature Measurements

Hyungdae Bae, David Yun, Haijun Liu, Douglas A. Olson, and Miao Yu

Abstract—We present a novel hybrid miniature dual-cavity Fabry–Perot sensor for simultaneous pressure and temperature measurements. The pressure sensing cavity is composed of an UV-molded cavity covered by a metal/polymer composite diaphragm for achieving a high pressure sensitivity while maintaining a miniature sensor size. Another intrinsic polymer/silica cavity is adopted for temperature sensing, which enables a high temperature sensitivity even with a short cavity length due to the large thermal expansion of the polymer. The sensor is fabricated by using a unique UV molding process with simple and safe procedures. The overall sensor size is around 150 μm in diameter and 343 μm in length. Experimental studies show that the sensor exhibits a good linearity over a pressure range of 6.89 to 27.58 kPa with a pressure sensitivity of 0.0122 $\mu\text{m}/\text{kPa}$ at 26 °C, and a temperature range of 26.0 °C to 50.0 °C with a temperature sensitivity of 0.0029 $\mu\text{m}/^\circ\text{C}$. An optical signal processing method is developed to retrieve the two cavity length changes, which is demonstrated to have a better resolution and a faster speed than the conventional method. The sensor is expected to benefit many fronts that require simultaneous pressure and temperature measurements with minimum intrusiveness, especially for biomedical applications.

Index Terms—Fabry–Perot (FP), fiber optics, optical sensors, optical signal processing.

I. INTRODUCTION

MINIATURE fiber optic Fabry–Perot (FP) sensors have attracted much interest for pressure monitoring due to their advantages of small size, high sensitivity, immunity to electromagnetism interference, and convenience of light guiding/detection through optical fibers [1]. Many different types of FP pressure sensors have been demonstrated. Most of these sensors are built with silicon/silica/ceramic materials [2]–[13] that

have good mechanical, chemical, and thermal stabilities. However, due to the large elastic modulus of silica/silicon/ceramic, developing a high sensitivity miniature sensor becomes difficult. In addition, fabrication of these sensors often involves high temperature and harsh acid. On the other hand, to realize a high sensitivity, polymer materials become an attractive choice for miniature pressure sensors [14]–[16], since its Young's modulus is significantly smaller than that of silicon/silica/ceramic. Moreover, polymer processes can be performed under ambient pressure and temperature without hazardous chemicals. However, a significant drawback of a polymer-based sensor is the high temperature sensitivity, which must be compensated to obtain accurate pressure measurements.

To compensate the temperature effect, one method is to include a fiber Bragg grating (FBG) as a temperature sensor in the pressure sensor design [16]–[19]. However, since the length of the embedded FBG is usually more than several millimeters, even when the FBG is placed close to the FP cavity, the temperature measuring location from the FBG is still away from the pressure sensing cavity, making it difficult to obtain the temperature at the pressure sensing location. Furthermore, this method often requires using a spectrometer with a large wavelength range or two separate spectrometers for resolving the spectra of both the FBG and FP sensors, which makes the system more expensive. In addition, adding a FBG sensor to a pressure sensor can increase the cost and complexity of the fabrication. Another method of temperature compensation is to employ another intrinsic FP cavity adjacent to the pressure sensing cavity. In a recent study [12], a segment of single mode fiber was used as an intrinsic FP cavity for temperature measurement. The sensor was fabricated by using hydrofluoric acid (HF) etching, fusion splicing, cleaving, and polishing processes. The pressure sensitivity and temperature sensitivity were measured to be 3.97 nm/kPa with a 17 μm cavity and 6.8 nm/K with a 1000 μm cavity, respectively.

In this article, design, fabrication, and experimental study of a polymer/silica hybrid miniature dual-cavity FP sensor is presented for simultaneous pressure and temperature sensing. As illustrated in Fig. 1, the pressure sensing structure employs a UV molded cavity covered by a polymer/metal composite diaphragm. The low elastic modulus of the polymer/metal composite diaphragm renders the sensor a high pressure sensitivity even with a miniature size. The temperature sensing is achieved by using an intrinsic silica/polymer FP cavity that is adjacent to the pressure sensing cavity. By taking advantage of the large coefficient of thermal expansion (CTE) of the polymer, the sensor

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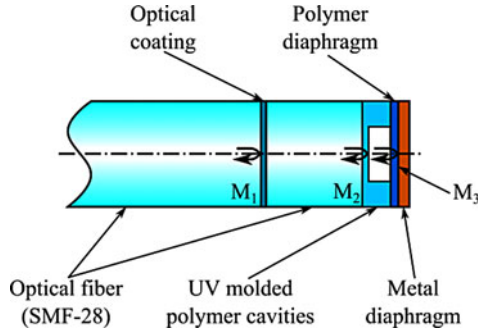


Fig. 1. Schematic of the hybrid temperature/pressure sensor.

can achieve a high temperature sensitivity with a short cavity length (the cavity length of the temperature sensing cavity: $284.8 \mu\text{m}$) 71.5% smaller than that of the previously reported sensor made of silica material [12]. The sensor fabrication employs simple and safe procedures without using hazard acid (e.g., HF) and most processes can be performed in batch fabrication by adopting a wafer scale fabrication technique [20], [21]. To retrieve both temperature and pressure information from the dual cavities, a frequency domain demodulation scheme that is capable of acquiring multiple cavity lengths is developed.

II. SENSOR DESIGN AND FABRICATION

The dual-cavity FP pressure sensor is designed to have built-in temperature measurement and compensation capability, which consists of a spliced segment of single mode fiber, a UV molded cavity structure, and a polymer/metal composite diaphragm used as a pressure transducer. The schematic of the sensor is shown in Fig. 1. One of the cavities is an air cavity formed between the end surface of the UV-molded cavity (M_2) and a polymer/metal composite diaphragm (M_3), which is sensitive to both pressure and temperature change. The other cavity is an intrinsic silica/polymer hybrid FP cavity formed between an internal mirror (M_1) generated from multi-layer dielectric films evaporated on a fiber endface and the end surface of the UV-molded cavity (M_2). Since the silica/polymer cavity is only sensitive to temperature, it is used for temperature measurement.

To achieve high sensitivity pressure measurement, a large cavity diameter is desirable. However, the size of the cavity diameter is limited by that of the optical fiber. In this paper, the diameter of the air cavity (i.e., the size of the diaphragm) was designed to be $80 \mu\text{m}$ since an $80\text{-}\mu\text{m}$ diameter fiber is used as the mold in the fabrication process. By using a finite element model of the composite diaphragm, the thicknesses of the polymer layer and the metal layer in the composite diaphragm were chosen to be 0.5 and $0.2 \mu\text{m}$, respectively. Note that these thicknesses were chosen to ensure high pressure sensitivity as well as to prevent the diaphragm from damage during the fabrication. The pressure sensitivity of the sensor was predicted to be $0.0145 \mu\text{m/kPa}$ at the room temperature. The air cavity length was designed to be $60 \mu\text{m}$ ensuring to have reasonably good number of fringes in the wavelength length range of the interrogation system.

On the other hand, in order to acquire a good temperature sensitivity, the silica/polymer cavity has to be properly designed. For a pure silica cavity, its temperature sensitivity can be expressed as

$$\begin{aligned} TS_{\text{silica}} &= \left(\frac{\alpha_{n_{\text{silica}}}}{n_{\text{silica}}} + CTE_{\text{silica}} \right) L_{\text{silica}} \\ &= (7.36 \mu\text{E}/^\circ\text{C}) L_{\text{silica}}, \end{aligned} \quad (1)$$

where $\alpha_{n_{\text{silica}}}$ is the thermo-optic coefficient, n_{silica} is the refractive index of the silica, CTE_{silica} is the CTE of silica, and L_{silica} is the length of the silica cavity. Since the thermo-optic coefficient ($1 \times 10^{-4} \text{ }^\circ\text{C}^{-1}$) and the CTE of silica ($0.55 \mu\text{E}/^\circ\text{C}$) are relatively low, in order to obtain a reasonable temperature sensitivity, the silica cavity length has to be relatively long [12]. However, a long cavity is not desirable in the design of a miniature fiber-optic sensor. To increase the temperature sensitivity of the sensor without increasing the length of the silica cavity, a thin polymer layer (OP-4-20632 UV curable polymer, Dymax)¹ with the refractive index of 1.553 (at 20°C and 589 nm wavelength) is added to the silica cavity, which has a CTE ($54 \mu\text{E}/^\circ\text{C}$) that is 98 times larger than that of silica and a thermo-optic coefficient of around $-3.6 \times 10^{-5} \text{ }^\circ\text{C}^{-1}$. Therefore, the overall temperature sensitivity of the silicon/polymer cavity can be rewritten as

$$\begin{aligned} TS_{\text{overall}} &= \left(\frac{\alpha_{n_{\text{silica}}}}{n_{\text{silica}}} + CTE_{\text{silica}} \right) L_{\text{silica}} \\ &+ \left(\frac{\alpha_{n_{\text{polymer}}}}{n_{\text{polymer}}} + CTE_{\text{polymer}} \right) L_{\text{polymer}} \\ &= (7.36 \mu\text{E}/^\circ\text{C}) L_{\text{silica}} + (30.32 \mu\text{E}/^\circ\text{C}) L_{\text{polymer}}, \end{aligned} \quad (2)$$

where $\alpha_{n_{\text{polymer}}}$ is the thermo-optic coefficient of the UV curable polymer, n_{polymer} is the refractive index of the polymer, CTE_{polymer} is the CTE of the polymer material, L_{polymer} is the length of the polymer cavity.

In this paper, the silica cavity length and the added polymer thickness were chosen to be 250 and $35 \mu\text{m}$, respectively, rendering a good temperature sensitivity of $0.0026 \mu\text{m}/^\circ\text{C}$. Because of the small refractive index difference between the UV curable polymer and the silica, the reflection at the silica/polymer interface is negligible. In addition, the relatively long cavity length of the silica ensures that there are enough number fringes in the interference spectrum and helps separate the optical frequency of the temperature sensing cavity from that of the pressure sensing cavity for easy signal processing.

In order to obtain accurate measurements from the two optical cavities, the two cavities should be carefully designed to ensure a good visibility of the multi-frequency interference fringes. Reflection from the internal mirror (M_1) can be tuned by changing

¹Certain commercial equipment, instruments, or materials are identified in this paper to foster understanding. Such identification does not imply endorsement by NIST nor does it imply that the equipment or materials are necessarily the best available for the purpose.

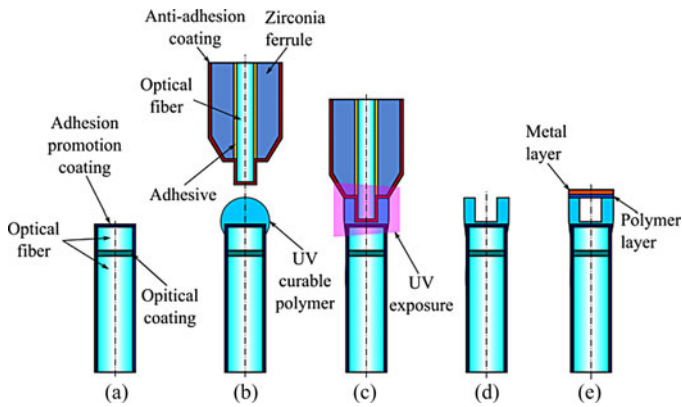


Fig. 2. Fabrication process of the hybrid UV-molded temperature/pressure sensor.

the number of alternating layers of TiO_2 and SiO_2 . Furthermore, the parameters used for splicing should also be well chosen to obtain proper reflectivity of M_1 for a good spectrum visibility. In this paper, the reflectivity of M_1 was chosen to be 4%, the same as that of M_2 that is due to the Fresnel reflection between polymer and air.

The sensor fabrication is composed of three steps. The first step is to splice a segment of single mode fiber that is used as part of the silica/polymer cavity for temperature measurement. The second step is to perform cavity molding. Finally, in the third step, a metal-polymer composite diaphragm is covered over the molded cavity. The detailed fabrication process is shown in Fig. 2. After a batch of single mode fibers (Corning, SMF-28e) were prepared by cleaving and cleaning, the fiber endfaces are coated with five alternating layers of TiO_2 and SiO_2 , each with a quarter wavelength thickness (at $\lambda = 850$ nm), by using electron beam evaporation. Another optical fiber was then spliced to the fiber with the optical coatings with empirically determined conditions to obtain the designed reflectivity ($\approx 4\%$). The splicing was performed with a commercial fusion splicer (Hamamatsu, Type-36) with 2 arc count and 0.5 s arc duration in order to get desired reflectivity from the fabricated internal mirror [22]–[24]. The fiber was then cleaved under a microscope to be around $250 \mu\text{m}$ away from the spliced location [see Fig. 2(a)]. Then, the prepared fiber is preliminarily aligned to a mold, constructed by using an $80\text{-}\mu\text{m}$ single mode optical fiber and a zirconia ferrule, under two optical microscopes with CCD cameras positioned with a 90° angle separation under the assistance of two five-axis manual stages. A small drop of a UV curable polymer is deposited at the end of the prepared fiber by retracting the fiber approximately by $500 \mu\text{m}$ [see Fig. 2(b)]. After this, the fiber with the deposited polymer is carefully moved toward the mold until the fiber endface touches the mold, followed by retracting with a precision stage to obtain a desired polymer thin film between the fiber mode and the endface of the sensing fiber [see Fig. 2(c)]. By using the optical fiber based mold, an accurate core-to-core alignment is enabled by monitoring the coupling intensity between the fiber and mold. A detailed description is provided in the author's previous work [16]. Further, post-baking is performed

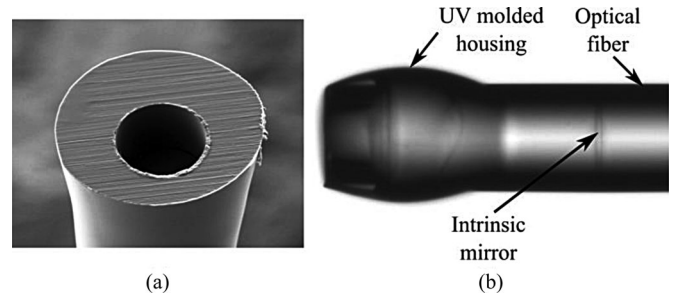


Fig. 3. (a) Close-up SEM of a molded cavity and (b) microscopic image of the fabricated sensor before depositing a metal layer.

as the last step of the polymer housing fabrication at 150°C for 5 h to achieve good thermal and mechanical stability of the UV-cured polymer housing. Finally, a polymer-metal composite layer is deposited on the housing structure to form a suspended diaphragm. The diaphragm fabrication process is as follows. A drop of UV curable polymer (OP-4-20641, Dymax) is dispensed onto the distilled water contained in a petri dish with 100 mm diameter. The dispensed polymer spreads out to form a uniform and thin layer. By controlling the volume of the dispensed polymer, the thickness of the thin polymer layer can be well controlled. The floating polymer layer is then half-cured on the water surface with a flood UV light source (Model 22-UV, Optical Engineering, INC) for 7 min, followed by lifting up the diaphragm from water and covering it on a batch of the molded cavities. Detailed polymer diaphragm covering process is provided in our previous work [25]. Additionally, a post UV-curing with a spot UV light source (Blue Wave 50AS, Dymax) for 100 s and thermal curing at 150°C for 3 h is performed to enhance the stability of the UV-curable polymer. This batch fabrication process ensures a good device-to-device uniformity and low fabrication cost. Finally, the polymer diaphragm is deposited with a titanium and silver layer using a direct current magnetron sputtering machine. A close-up scanning electron micrograph (SEM) of the molded cavity and a microscopic image of the fabricated sensor before covering a metal layer are shown in Fig. 3.

III. OPTICAL INTERROGATION AND SIGNAL PROCESSING

In the experiment, the fabricated sensor was connected to a broadband optical interrogation system, which is consisted of a 2×2 coupler (Gould Fiber Optics), a broadband spectrometer (USB4000, Ocean Optics) with 0.4 nm wavelength resolution, and a broadband light source (HL-2000, Ocean Optics). The broadband spectrometer has a large wavelength bandwidth from 700 to 1000 nm, which ensures a good optical frequency resolution in the data processing using fast Fourier transform (FFT). The experimental arrangement for pressure and temperature calibration is illustrated in Fig. 4. The spectrum of the multi-cavity FP sensor has a combination of distinctive optical frequencies, which are defined by the air cavity, silica/polymer cavity, and the combination of those two cavities. The total intensity of

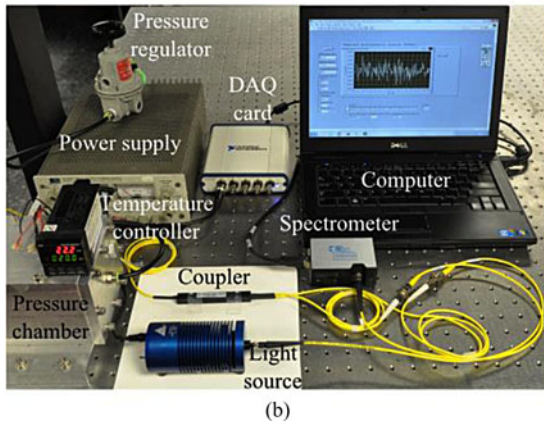
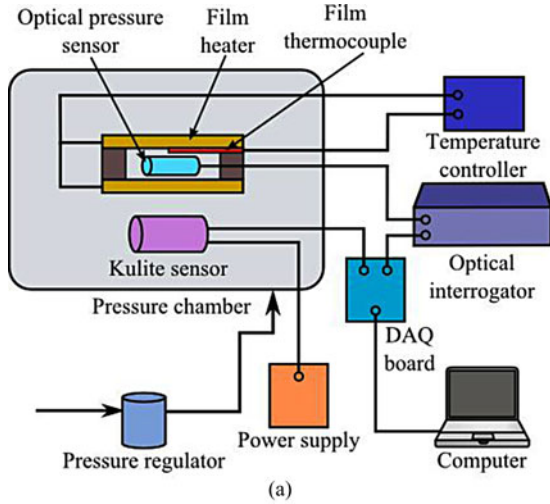


Fig. 4. Experiment arrangement for pressure measurement: (a) schematic and (b) photograph of the setup.

interference can be written as [26]

$$\begin{aligned}
 I(\lambda) &= \left| A_1 - A_2 \exp\left(-\frac{j4\pi(n_{\text{silica}}L_{\text{silica}} + n_{\text{polymer}}L_{\text{polymer}})}{\lambda}\right) + A_3 \exp\left(-\frac{j4\pi(n_{\text{silica}}L_{\text{silica}} + n_{\text{polymer}}L_{\text{polymer}} + L_{\text{air}})}{\lambda}\right) \right|^2 \\
 &= A_1^2 + A_2^2 + A_3^2 - 2A_1A_2 \cos\left(\frac{4\pi(n_{\text{silica}}L_{\text{silica}} + n_{\text{polymer}}L_{\text{polymer}})}{\lambda}\right) \\
 &\quad - 2A_2A_3 \cos\left(\frac{4\pi(L_{\text{air}})}{\lambda}\right) + 2A_3A_1 \cos\left(\frac{4\pi(n_{\text{silica}}L_{\text{silica}} + n_{\text{polymer}}L_{\text{polymer}} + L_{\text{air}})}{\lambda}\right), \quad (3)
 \end{aligned}$$

where A_1 , A_2 , and A_3 are the amplitudes of the reflected electric fields that are related to reflectivity of the internal mirror, the air cavity bottom surface, and the composite diaphragm, respectively, L_{air} is the length of the air cavity, and λ is the free-space wavelength.

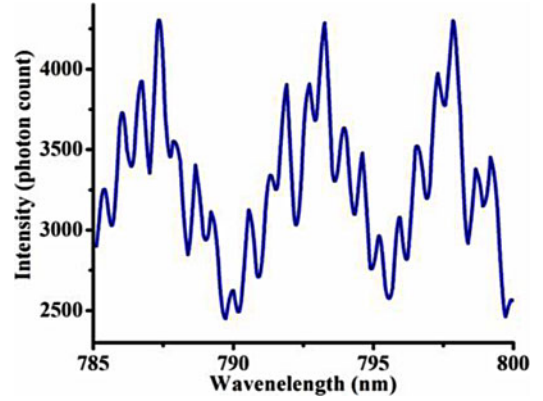


Fig. 5. Interference spectrum of the fabricated sensor obtained with the broadband interrogation system.

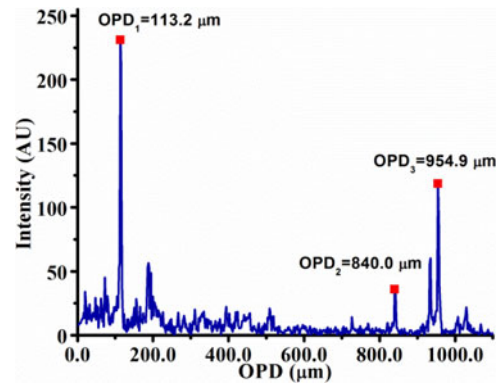


Fig. 6. FFT result from the wavenumber spectrum of the sensor.

A representative interference spectrum obtained from the sensor by using the broadband optical interrogation system is shown in Fig. 5. The low frequency waveform in the spectrum corresponds to the air cavity and the high frequency modulations are due to the silica/polymer cavity and the combination of the two cavities.

In order to retrieve the two cavities independently, optical frequency domain signal processing was adopted. The acquired wavelength spectrum was first converted to the wavenumber domain. Since the obtained wavenumber spectrum is not evenly spaced, cubic spline interpolation and resampling were performed. An FFT of the resampled spectrum was carried out and the optical path differences (OPDs) were determined based on the FFT results. The relationship between the measured OPD and the optical cavity length can be described as

$$\text{OPD} = 2nL = f, \quad (4)$$

where L is the optical cavity length, and n is the refractive index of the FP cavity. Fig. 6 shows the FFT result of a sensor wavenumber spectrum. The three peaks shown in the figure correspond to the air cavity, the silica/polymer cavity, and the combination of the two cavities. The cavity lengths obtained from the FFT result are 56.62 and 284.83 μm , respectively, for the air cavity and the silica/polymer cavity. However, the FFT results only provide limited resolution in the cavity lengths due to the limited wavelength range (700 to 1000 nm) of the

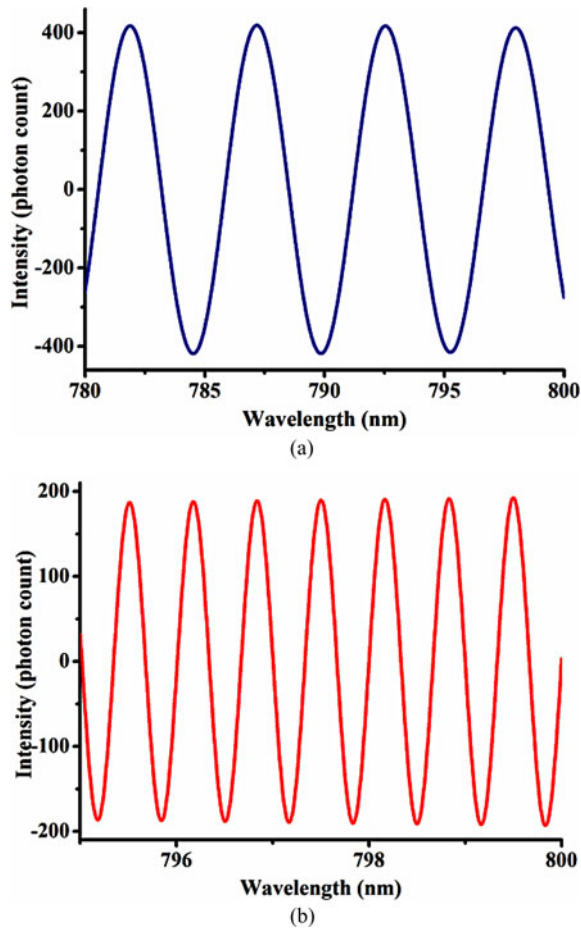


Fig. 7. Filtered wavelength spectrum for (a) the air cavity and (b) the combined cavity of air and silica/polymer. The dc component of the intensity was removed.

spectrometer [27]. Increasing the wavelength range is costly and can result in a reduced sampling rate of the detection system. In order to achieve a better accuracy of the cavity lengths without compromising the sampling rate, a method that makes use of curve fitting of the filtered spectrum has been previously reported [28]. However, this method is computationally costly since it needs to utilize the entire spectrum to obtain a fitted curve and requires iterative calculations.

In this paper, a novel signal processing scheme is developed, which makes use of selective curve fitting to the filter spectrum and combines with the one peak tracing method [29]. In this method, the measured optical frequencies from the FFT result are used as the center frequencies of band-pass Butterworth filters to extract the single frequency wavelength spectrum at the frequency of interest. Fig. 7 shows the filtered wavelength spectra by using two different band-pass filters whose center frequencies are corresponding to the two peaks (OPD_1 and OPD_3) in the FFT result shown in Fig. 6. After obtaining the spectrum with a single frequency matching to each cavity length, curve fitting is performed only at the peak region of the spectrum. The one peak tracing method is then used to retrieve the value of the cavity length.

By using this method, the cavity length can be determined with a high resolution (0.2 nm with USB4000 spectrometer) due

to the nature of the one peak tracking method [29]. The resolution was determined by measuring the root-mean-square error of the cavity length measurement. This resolution is much higher than that obtained directly from the FFT method (845.1 nm with the same spectrometer). The resolution of the FFT method was determined by minimum theoretical step size of the cavity length measurement (i.e., the maximum achievable resolution). The resolution of the FFT method is limited by the wavelength range of the spectrometer (700–1000 nm) used in the measurement. Furthermore, the calculation time can be reduced significantly (around 19 times faster according to the simulations) compared to the band-pass filtering and spectrum curve fitting method [28] because in this paper the curve fitting is only performed at the vicinity of each peak.

A parametric study was carried out to compare the performance of the demodulation scheme developed in this paper with the previously reported method in terms of calculation time and linearity of the cavity measurements. In the simulations, a sensor with two cavities with initial cavity lengths of 60 and 300 μm were used. Both of the two cavity lengths were varied by 0.05 μm with a step of 0.001 μm (i.e., 60.000 μm cavity was increased to 60.050 μm and 300.000 μm cavity to 300.050 μm with 0.001 μm step). Random noise was introduced to the interference signals in the simulation to simulate inherent noise of a spectrometer and a light source. The cavity length changes were retrieved from the simulated spectrum by using the full spectrum curve fitting method [28] and the method developed in this paper. R^2 values of the determined cavity length as a function of the true cavity length were obtained and plotted as a function of signal-to-noise ratio (SNR) for the two different methods, shown in Fig. 8. It can be seen that both methods were able to retrieve the cavity length change with a good linear performance when the SNR is high. However, when the SNR is low, the method developed in this paper shows a better resilience to noise over the previous method. Moreover, it was found during the simulations that the method developed in this paper was about 19 times faster with a calculation speed of 0.46 s per data point, while for the previously reported method, the calculation speed was 8.71 s per data point.

IV. SENSOR CALIBRATION

The calibration of the sensor for pressure measurement was performed in a pressure chamber with a reference pressure sensor, as shown in Fig. 4. A conventional pressure sensor (LL-080–35A, Kulite Semiconductor) with a pressure uncertainty of 1% or 3.35 kPa in the pressure range of 0 to 344.74 kPa was used as the reference. The internal chamber pressure was controlled by using a pressure regulator (Pressure Regulator Type 70, Marsh Bellofram), which has a gauge mode pressure range of 0 to 206.84 kPa. Temperature control was achieved by using a temperature controller (Omega Engineering Inc., CN77333), a polyimide-insulated flexible thermocouple (Omega Engineering Inc., CO1-K) with an uncertainty of 1.5% or 4.0 $^{\circ}\text{C}$ in the temperature range of 0 to 260 $^{\circ}\text{C}$, and two polyimide-insulated flexible heaters (Omega Engineering Inc., KH 103/10). The heaters were placed above and below the sensor to control the temperature

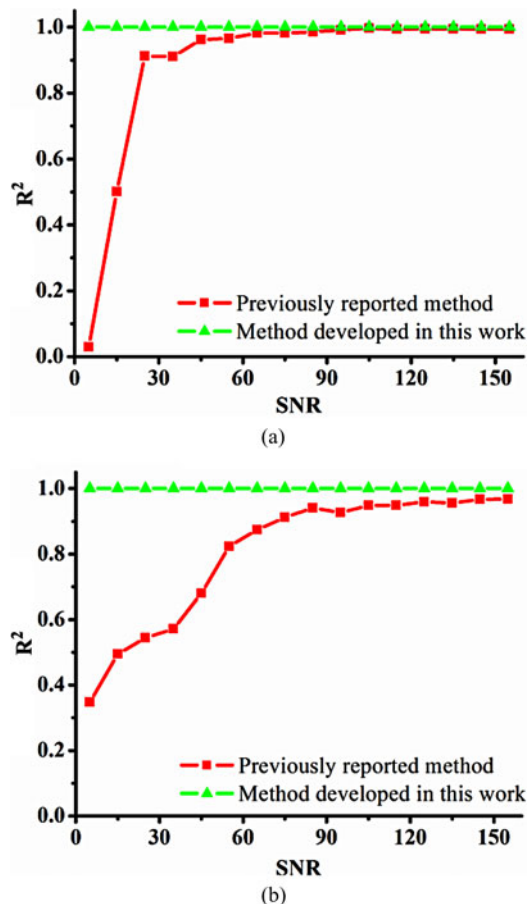


Fig. 8. Comparison of R^2 values as a function of SNR by using two different demodulation schemes (spectrum curve fitting and one peak tracking of the filtered spectrum) for cavity lengths: (a) $60 \mu\text{m}$ and (b) $300 \mu\text{m}$. SNR was calculated as the signal power divided by the noise power.

locally, while minimizing the heating time and the temperature effect on the reference pressure sensor.

In the experiments, at a room temperature of 26°C , the pressure in the chamber was first increased and then decreased with a step of 1.38 kPa within a range of 6.89 to 27.58 kPa . The calibration result of the sensor is shown in Fig. 9. It can be seen that the sensor exhibits a good linearity ($R^2 = 0.9993$) over the entire tested pressure range. Based on the linear regression analysis of the measured data, the pressure sensitivity was calculated to be $0.0122 \mu\text{m/kPa}$ with an uncertainty of $0.0002 \mu\text{m/kPa}$ (1.6%). This result is slightly smaller than the predicted value obtained from the numerical simulations ($0.0145 \mu\text{m/kPa}$). Residual stresses generated during the polymerization and metallization process of the diaphragm are the possible reasons for the lower measured sensitivity. Furthermore, the sputtering process induced a curvature in the diaphragm, which further reduces the pressure sensitivity. To obtain the pressure resolution, the cavity length was first measured for a fixed pressure level at the room temperature and the root mean square (RMS) error of the cavity length was calculated. Note that the RMS error represents the noise floor of the cavity length measurement, which is determined by the overall noise of the measurement

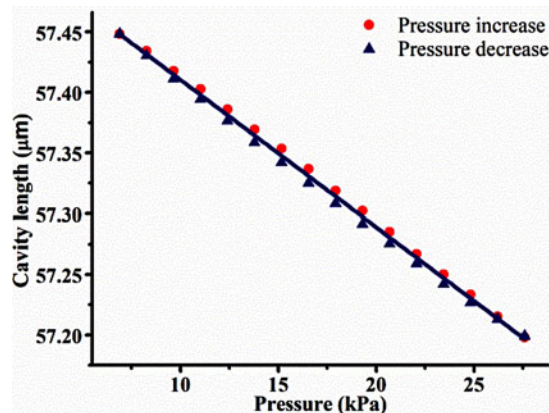
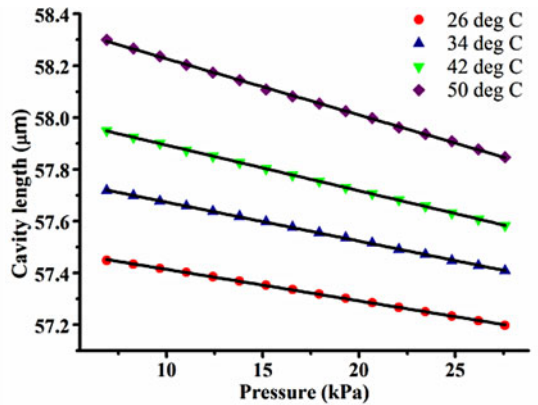


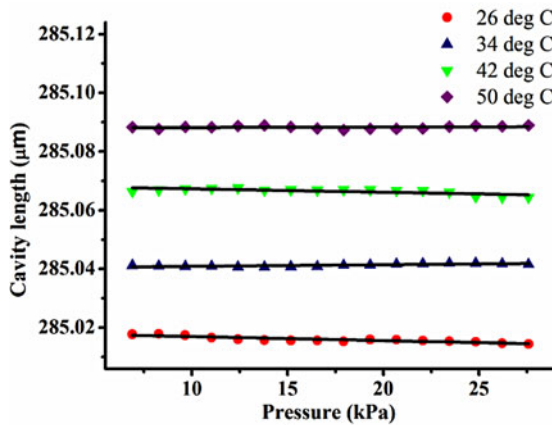
Fig. 9. Pressure calibration curves of the sensor at 26.0°C .

system including the sensor and the optical interrogation system. Therefore, the pressure resolution can be obtained by using the RMS error divided by the measured pressure sensitivity of the sensor. Based on this method, the pressure resolution of the FP pressure sensor was determined to be 0.021 kPa . The sources of the noise in the pressure measurement include the mechanical–thermal noise of the pressure sensor and the noise of the optical interrogation system. Based on the Nyquist relation [30], the sensor mechanical–thermal noise was calculated to be 2.5% of the overall noise floor. Therefore, the noise of the optical interrogation system is the dominant noise source, which includes the shot-noise, the thermal-noise, the amplifier noise of the spectrometer, and the relative intensity noise of the light source [31]. In addition, the hysteresis error and the pressure uncertainty of the sensor were obtained to be 0.476 (2.3%) and 0.126 kPa (0.6%), respectively. The small zero drift and non-linearity of the calibration curves are believed to be mainly due to temperature variations of the environment ($\sim 0.2^\circ\text{C}$) since the temperature was not controlled to be constant during the pressure calibrations.

To evaluate the temperature effect, the pressure sensitivities for both the air cavity and the silica/polymer cavity were obtained at different temperatures (e.g., 26 , 34 , 42 , and 50°C) by using the experimental setup shown in Fig. 4. The pressure calibration result of the air cavity is shown in Fig. 10(a). In all four cases, the measurement results show good linearity ($R^2 > 0.9994$) over the measured pressure range. However, it can be seen that pressure sensitivities have temperature dependency. The deviation of the sensitivity value is believed to be due to the Young's modulus change of the polymer layer in the polymer/metal composite diaphragm and the UV molded cavity due to the temperature. In Fig. 10(b), the pressure sensitivities of the silica/polymer cavity at the four different temperatures are plotted. It can be seen that due to the high elastic modulus of silica (71.7 GPa), the cavity length change of the temperature sensing cavity with respect to pressure is negligible in the pressure range of 6.89 to 27.58 kPa for all four temperatures. The slight fluctuations of the cavity length are believed to be mainly due to temperature fluctuations from the temperature controller.



(a)



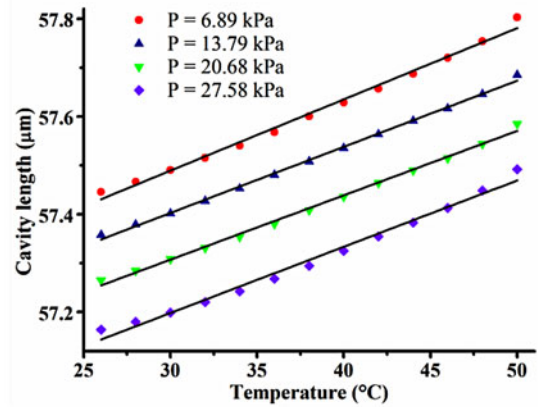
(b)

Fig. 10. Pressure calibration curves: (a) air cavity and (b) silica/polymer cavity at four different temperatures (26.0, 34.0, 42.0, and 50.0 °C).

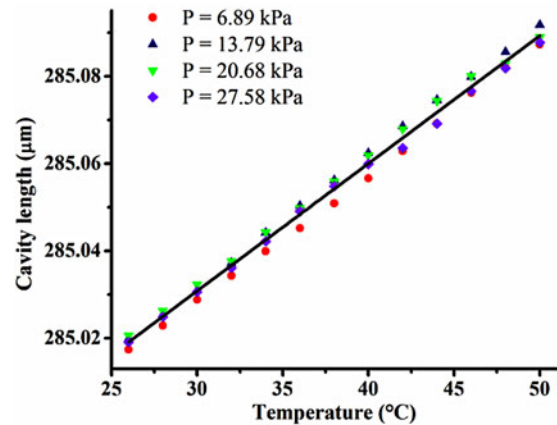
V. TEMPERATURE SENSITIVITY AND TEMPERATURE COMPENSATION

As discussed previously, the silica/polymer FP cavity in the fabricated sensor can be used as a temperature sensor due to its linear response to temperature change and low pressure sensitivity. In addition, the temperature reading from the silica/polymer cavity can be used to compensate for the relatively large temperature drift of the pressure sensing cavity. To evaluate the temperature sensing performance of the silica/polymer cavity and the temperature compensation capability of the sensor, temperature calibration of the two cavities was performed in the pressure chamber with a temperature controller, as shown in Fig. 4.

First, the temperature sensitivity of the air cavity was evaluated. In the experiment, the temperature sensitivity of the cavity was measured by monitoring the cavity length change of the air FP cavity with respect to the temperature change. To measure the temperature sensitivity, the sensor was heated from 26 to 50 °C with an increment of 2 °C under four different pressure levels 6.89, 13.79, 20.68, and 27.58 kPa. The cavity lengths were recorded as a function of temperature at each pressure level. The obtained temperature calibration results of the air FP cavity are shown in Fig. 11(a). According to the result, a linear relationship between the air cavity length and temperature can



(a)



(b)

Fig. 11. Temperature calibration curves: (a) air cavity and (b) silica/polymer cavity at four different pressure levels of 6.89, 13.79, 20.68, and 27.58 kPa.

be observed with a good linearity ($R^2 > 0.9881$) and a sensitivity of $0.0137 \mu\text{m}/^\circ\text{C}$ with an uncertainty of $0.0003 \mu\text{m}/^\circ\text{C}$ (2.2%).

Next, the temperature sensitivity and temperature resolution of the silica/polymer FP cavity were investigated. By using the same experimental arrangement and method, the temperature calibration results for the silica/polymer cavity at several different pressures were obtained, as shown in Fig. 11(b). The calibration results exhibit a good linearity ($R^2 > 0.9984$) and the pressure sensitivity of the silica/polymer cavity is found to be negligible. The temperature sensitivity and resolution of the silica/polymer cavity of the FP pressure sensor were obtained as $0.0029 \mu\text{m}/^\circ\text{C}$ with an uncertainty of $0.0001 \mu\text{m}/^\circ\text{C}$ (3.4%) and 0.10°C , respectively. The uncertainty of the temperature measurement was 0.03°C (0.14%). By using the hybrid silica/polymer cavity, a high temperature sensitivity as well as a high resolution can be achieved with a smaller form factor compared to the sensor made of pure silica.

In order to compensate for the temperature effect of the pressure sensing cavity, the temperature readings from the silica cavity are used along with the temperature sensitivity of the air cavity. Based on Fig. 11(b), the relationship between the silica/polymer cavity length and the temperature can be obtained

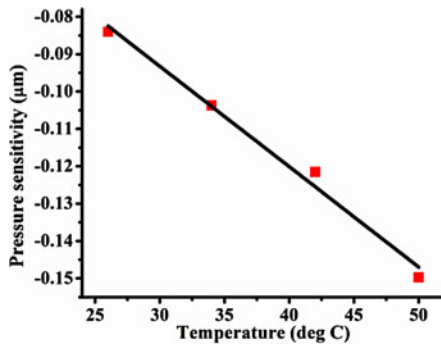


Fig. 12. Pressure sensitivity of the air cavity as a function of temperature.

as

$$T = (L_{\text{silica/polymer}} - L_{\text{silica/polymer}}^0) / TS_{\text{silica/polymer}} + T^0, \quad (5)$$

where T is the measured temperature, T^0 is the initial temperature, $L_{\text{polymer/silica}}$ is the cavity length of the silica/polymer cavity, $L_{\text{silica/polymer}}^0$ is the initial cavity length of the silica/polymer cavity, and $TS_{\text{silica/polymer}}$ is the temperature sensitivity of the silica/polymer cavity.

It is noted that the pressure sensitivity of the sensor varies from 0.0122 to 0.0218 $\mu\text{m}/\text{kPa}$ in the temperature range of 26 to 50 $^{\circ}\text{C}$. This large sensitivity change is believed to be due to softening of the polymer layer in the polymer/metal composite diaphragm. Also, this change was found to be reversible. The pressure sensitivity as a function of the temperature is shown in Fig. 12, which was found to be a linear function. Based on this figure, the pressure sensitivity can be obtained at any temperature as

$$PS_{\text{air cavity}}(T) = (0.00269T + 0.0018) \mu\text{m}/\text{kPa}, \quad (6)$$

where $PS_{\text{air cavity}}$ is the pressure sensitivity of the air cavity and T is the temperature. The measured pressure sensitivity can then be used to compensate the temperature effect. As shown in Figs. 10 and 11, the lengths of the air and the silica/polymer cavities change linearly with respect to both pressure and temperature. Therefore, the temperature-compensated pressure can be expressed as the following:

$$P = \frac{(L_{\text{air}} - TS_{\text{air cavity}}(T - T^0) - L_{\text{air}}^0)}{-PS_{\text{air cavity}}(T)} + P^0 \quad (7)$$

where P is the measured pressure, L_{air} is the cavity length of the air cavity, L_{air}^0 is the initial cavity length of the air cavity, $TS_{\text{air cavity}}$ is the temperature sensitivity of the air cavity, and P^0 is the initial pressure. Based on (5) and (7), the temperature and pressure values can be retrieved simultaneously from the measurement results of the two FP cavity length changes.

VI. CONCLUDING REMARKS

In this article, a hybrid dual Fabry–Pérot cavity fiber optic pressure and temperature sensor is presented. The sensor, which is made at the end of a single mode fiber, is composed of an air cavity for pressure sensing and a polymer/silica hybrid cavity for temperature sensing. The dual cavity design renders the

sensor the capability of temperature compensation and simultaneous pressure and temperature measurements. The fabrication of the extrinsic air cavity was performed by using a unique UV molding process with an optical fiber based mold. The intrinsic silica/polymer cavity formed between several layers of dielectric optical coating and the bottom surface of the UV molded cavity enables a high temperature sensitivity of the sensor with a small cavity length, owing to the large thermal expansion of the polymer material. Due to the relatively low stiffness of the polymer/metal composite diaphragm, a sensor with a miniature size but having a high sensitivity can be obtained. Experimental studies have shown that the sensor has good linearity for pressure measurement in the designed pressure range. Effective temperature measurement by using the embedded intrinsic silica/polymer cavity has also been demonstrated. Furthermore, a novel signal processing method has been developed for demodulation of multiple cavity lengths for multiplexed FP sensors or a FP sensor with multiple cavities. Compared with the previous methods, this method renders much shorter calculation time, higher resolution, and better resilience to noise.

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